



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2812  
Examiner: To be assigned

In Re PATENT APPLICATION OF:

Applicant(s) : Muh Wang LIANG et al.

Serial No. : 09/619,388

Filed : July 19, 2000

For : APPARATUS FOR  
LOADING/UNLOADING WAFERS TO  
AND FROM SEMICONDUCTOR  
FABRICATION EQUIPMENT

Attorney Ref: LIE 105

**STATUS REQUEST**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please let us know the status of the above-identified application and when an Action may be expected. Please respond via facsimile or e-mail Tonya Harris (Docketing Manager) at [tonya@rabinchamp.com](mailto:tonya@rabinchamp.com).

Respectfully submitted,

*Steven M. Rabin*

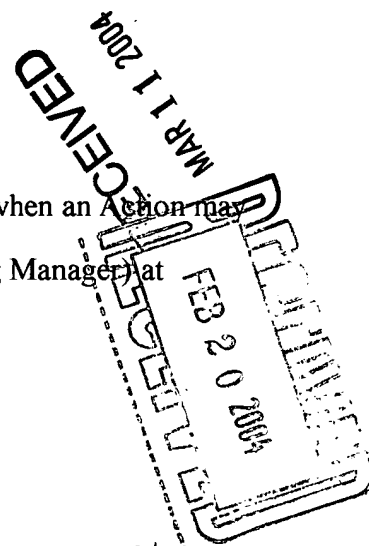
January 21, 2004

Date

SMR:dt

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